In the Claims

This listing of claims will replace all prior versions, and listings, of claims in the application:

Please amend claims 1, 2, 6, 8, 9-11, 13 cancel claims 3-4 and add claims 15-19.

Listing of Claims

1. (Currently amended) A polarizer manufacturing method, said method comprising: placing a <u>dichroic</u> material on a dip-pen;

bringing said dip-pen into contact with a <u>polarizer</u> base to transfer said <u>dichroic</u> material to said base <u>to form a pattern on the polarizer base</u>; and

hardening said dichroic material over said polarizer base.

- 2. (Currently amended)The polarizer manufacturing method according to claim 1, wherein a hardening process is used to drying dry said dichroic material.
 - 3. (Cancelled)
 - 4. (Cancelled)
- 5. (Original)The polarizer manufacturing method according to claim 1, wherein said dippen is a tip of an Atomic Force Microscope (AFM).
- 6. (Currently amended)The polarizer manufacturing method according to claim 1, wherein said <u>dichroic material is materials are</u> transferred to the polarizer base by capillarity.

- 7. (Original)The polarizer manufacturing method according to claim 1, wherein a transparent macromolecule material or glass is used to form the polarizer base.
 - 8. (Currently amended) A polarizer manufacturing method, said method comprising: forming a <u>polarizer</u> material on a dip-pen;

<u>bringing</u> said dip-pen into contact with a base to transfer said <u>polarizer</u> material to said base; <u>and</u>

hardening said polarizer material over said polarizer base forming a protection layer over a surface of said base; and performing a hardening process to harden said protection layer.

- 9. (Currently amended)The polarizer manufacturing method according to claim 8, wherein a hardening process is used to drying dry said polarizer material.
- 10. (Currently amended)The polarizer manufacturing method according to claim 8, wherein said <u>polarizer</u> material is dichroic material.
- 11. (Currently amended)The polarizer manufacturing method according to claim 8, wherein said <u>polarizer</u> material is birefringent material.
- 12. (Original)The polarizer manufacturing method according to claim 8, wherein said dippen is a tip of an Atomic Force Microscope (AFM).
- 13. (Currently amended) The polarizer manufacturing method according to claim 8, wherein said polarizer material is materials are transferred to the polarizer base by capillarity.

- 14. (Original)The polarizer manufacturing method according to claim 8, wherein a transparent macromolecule material or glass is used to form the polarizer base.
 - 15. (New) A polarizer manufacturing method, said method comprising:

placing a birefringent material on a dip-pen;

bringing said dip-pen into contact with a polarizer base to transfer said material to said polarizer base to form a pattern on the polarizer base; and

hardening said birefringent material over said polarizer base.

- 16. (New) The polarizer manufacturing method according to claim 15, wherein a hardening process is used to dry said birefringent material.
- 17. (New) The polarizer manufacturing method according to claim 15, wherein said dippen is a tip of an Atomic Force Microscope (AFM).
- 18. (New)The polarizer manufacturing method according to claim 15, wherein said birefringent material is transferred to the polarizer base by capillarity.
- 19. (New) The polarizer manufacturing method according to claim 15, wherein a transparent macromolecule material or glass is used to form the polarizer base.